

JUN 21 2005

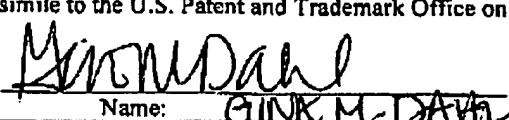
S/N 10/700,290

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Negami, et al.	Examiner:	M. H. Tran
Serial No.:	10/700,290	Group Art Unit:	2818
Filed:	11/03/2003	Docket No.:	10873.1338US01
Title:	ELECTRONIC DEVICE AND METHOD FOR MANUFACTURING THE SAME		

CERTIFICATE UNDER 37 CFR 1.6(d):

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on June 21, 2005.

By: 
Name: GINK M. DAHL

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Dear Sir:

In response to the Office Action mailed March 21, 2005, favorable reconsideration of this application is requested in view of the following remarks.

Claim 1 was rejected as being anticipated by Tanaka (US 5,236,894). Applicants traverse this rejection.

Claim 1 requires an electronic device comprising an oxide layer, wherein the oxide layer comprises an oxide comprising an element from group IIa, an element from group IIb and an element from group IIIb. Tanaka is directed to an oxide superconductor. The designations used by Tanaka are for element groups based on a different version of the periodic table from that used for the present invention. The group IIIb element of the present claim 1, as seen in present claim 3, is the group that includes B, Al, Ga, In, etc. On the other hand, Tanaka's group IIIB is the group that includes Sc, Y, or lanthanoid series elements (see Tanaka claims 7-9). To clarify